

Electronic Acknowledgement Receipt

EFS ID:	3539640
Application Number:	10597200
International Application Number:	
Confirmation Number:	7656
Title of Invention:	Gallium Nitride-Based III-V Group Compound Semiconductor Device and Method of Manufacturing the Same
First Named Inventor/Applicant Name:	Jong-Lam Lee
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Attorney Docket Number:	3576-022
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Application Type:	U.S. National Stage under 35 USC 371

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	P2381US00-IDSTransmittal.pdf	774538 2aaf29b5b4661d33bde702cbee98a5959 ca95065	no	4

Warnings:

Information:

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2	NPL Documents	P2381US00-EuropeanSearchReport.pdf	66130 e45ebdd673981a483e5d20143d32f3489d29b	no	3
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Information:

3	Foreign Reference	P2381US00-WO01-47038.pdf	637558 1968f3d39d43014a880c4319f0f930485c44d07	no	20
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4	Foreign Reference	P2381US00-EP1168460.pdf	1524844 a851b5a54702b4062009b3813b4c47e6c5ae5f90	no	30
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5	Foreign Reference	P2381US00-EP0926744.pdf	478388 3fe7e507ed2c499996d3bc8008f9e99314d7f666	no	9
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